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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/751,478	01/06/2004	Minoru Matsuzawa	031362	3528
23850 7	7590 03/07/2006		EXAM	INER
ARMSTRON 1725 K STREE	IG, KRATZ, QUINTO	ABDELWAHED, ALI F		
SUITE 1000	31,1111		ART UNIT	PAPER NUMBER
WASHINGTO	N, DC 20006		3722	

DATE MAILED: 03/07/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

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		Application No.	Applicant(s)			
Office Action Summary		10/751,478	MATSUZAWA ET AL.			
		Examiner	Art Unit			
		Ali Abdelwahed	3722			
Period fo	The MAILING DATE of this communication ap or Reply	pears on the cover sheet with the	correspondence address			
WHIC - Exte after - If NC - Failu Any	ORTENED STATUTORY PERIOD FOR REPL CHEVER IS LONGER, FROM THE MAILING D nsions of time may be available under the provisions of 37 CFR 1. SIX (6) MONTHS from the mailing date of this communication. O period for reply is specified above, the maximum statutory period are to reply within the set or extended period for reply will, by statut reply received by the Office later than three months after the mailing ed patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNICATION 136(a). In no event, however, may a reply be time the second will expire SIX (6) MONTHS from the cause the application to become ABANDONE	N. mely filed n the mailing date of this communication. ED (35 U.S.C. § 133).			
Status	·					
1)	Responsive to communication(s) filed on	•				
	This action is FINAL . 2b)⊠ This action is non-final.					
3)□	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
	closed in accordance with the practice under	Ex parte Quayle, 1935 C.D. 11, 4	53 O.G. 213.			
Disposit	ion of Claims					
5)□ 6)⊠ 7)□	Claim(s) <u>1-7</u> is/are pending in the application. 4a) Of the above claim(s) is/are withdra Claim(s) is/are allowed. Claim(s) <u>1-7</u> is/are rejected. Claim(s) is/are objected to. Claim(s) are subject to restriction and/o	awn from consideration.				
Applicat	ion Papers					
10)	The specification is objected to by the Examine The drawing(s) filed on is/are: a) acc Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct The oath or declaration is objected to by the E	cepted or b) objected to by the edrawing(s) be held in abeyance. Section is required if the drawing(s) is ob	e 37 CFR 1.85(a). pjected to. See 37 CFR 1.121(d).			
Priority (under 35 U.S.C. § 119					
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received.						
Attachmen	ut(s) ce of References Cited (PTO-892)	4) 🔲 Interview Summary	/ (PTO-413)			
2) Notice (3) Information	ce of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB/08 or No(s)/Mail Date 6/7/04.	Paper No(s)/Mail D				

U.S. Patent and Trademark Office PTOL-326 (Rev. 7-05) Application/Control Number: 10/751,478

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DETAILED ACTION

Claim Objections

Claim 1 is objected to because of the following informalities:

It is suggested that in:

Claim 1, line 2, delete "check" and insert -chuck--.

Appropriate correction is required.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1 and 2 are rejected under 35 U.S.C. 102(b) as being anticipated by U.S. Patent No. 5,717,482 to Akutsu et al.

Akutsu et al. discloses a substrate supporting apparatus (1) comprising a rotatable chuck (2) which is provided at its central portion with a hollow (see figs.1-3) and which supports a substrate (3), and a cylindrical nozzle member (10) having a nozzle hole (11) and capable of vertically moving in the hollow (see figs.1, 2). The nozzle hole is formed in a central portion of the nozzle member (see figs.1-3), and means (13, 14) for upwardly moving the nozzle member (see figs.1, 2, 5).

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Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claim 3 is rejected under 35 U.S.C. 103(a) as being unpatentable over Akutsu et al. in view of U.S. Patent No. 5,896,877 to Pirker.

Akutsu et al. discloses the claimed invention except for a plurality of pawls provided on a surface of the chuck opposed to the substrate, each of the pawls being projected substantially in a perpendicular direction with respect to the surface, each of the pawls can move into a state in which the pawls abut against an outer periphery of the substrate and support the substrate, and into a state in which the pawls are separated from the outer periphery of the substrate. However, Pirker teaches a substrate supporting apparatus (1) comprising a plurality of pawls (7) provided on a surface of the chuck opposed to the substrate (see fig.1), each of the pawls being projected substantially in a perpendicular direction with respect to the surface (see fig.1), each of the pawls can move into a state in which the pawls abut against an outer periphery of the substrate and support the substrate (see fig.1), and into a state in which the pawls are separated from the outer periphery of the substrate (see column 2, lines 3-5). Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the apparatus of Akutsu et al., in view of Pirker, such that it would provide the apparatus of Akutsu et al. with the concept of the

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aforementioned limitations for the purpose of enhancing the support of the substrate on the chuck.

Claims 4 and 5 are rejected under 35 U.S.C. 103(a) as being unpatentable over Akutsu et al. in view of U.S. Patent No. 6,095,582 to Siniaguine et al.

Akutsu et al. discloses the claimed invention except for the substrate is held over an upper surface of the chuck in a non-contact state by discharging gas from the nozzle hole. However, Siniaguine et al. teaches a substrate supporting apparatus (110) comprising a substrate (120) being held over an upper surface of the chuck (130) in a non-contact state by discharging gas from the nozzle hole 200 (see fig. 2, and column 1, lines 26-30 and 61-67). Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the apparatus of Akutsu et al., in view of Siniaguine et al., such that it would provide the apparatus of Akutsu et al. with the concept of the aforementioned limitation for the purpose of providing a more efficient support of the substrate on the chuck.

Claims 6 and 7 are rejected under 35 U.S.C. 103(a) as being unpatentable over Akutsu et al. in view of Siniaguine et al. as applied to claim 4 above, and further in view of U.S. Patent Application Publication No. 2001/0052392 A1 to Nakamura et al.

Akutsu et al., as modified, discloses the claimed invention except for having a fork with a pair of finger portions for holding the substrate. However, Nakamura et al. teaches a substrate supporting apparatus comprising a fork (44) with a pair of finger

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portions for holding the substrate (see fig.13). Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to further modify the apparatus of Akutsu et al., as per the teachings of Nakamura et al., such that it would provide the apparatus of Akutsu et al. with the concept of the aforementioned limitation for the purpose of providing a more efficient device for holding the substrate.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ali Abdelwahed whose telephone number is (571) 272-4417. The examiner can normally be reached Monday through Friday from 10:00 A.M. to 6:30 P.M.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Boyer Ashley can be reached on (571) 272-4502.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the examiner or the examiner's supervisor.

AA 02/27/2006

> BOYER D. ASHLEY SUPERVISORY PATENT EXAMINER